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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77402

Motoaki MATSUDA

Allowed: December 7, 2004

Appln. No.: 10/659,379

Group Art Unit: 2818

Confirmation No.: 2997

Examiner: David NHU

Filed: September 11, 2003

For: FLIP-CHIP BGA SEMICONDUCTOR DEVICE FOR ACHIEVING A SUPERIOR
CLEANING EFFECT

SUBMISSION OF ART

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

For the possible benefit of anyone subsequently evaluating the scope and/or validity of the above-identified patent, it is requested that the document that is listed below (copy enclosed) be placed in the U.S. Patent and Trademark Office's file wrapper of the above-identified U.S. patent:

1. Japanese Patent Application Publication No. 11-102941, published April 13, 1999 (with English abstract).

The above-listed document was recently cited in a Korean Office Action, dated August 30, 2005, a copy of which is enclosed along with a Japanese translation thereof.

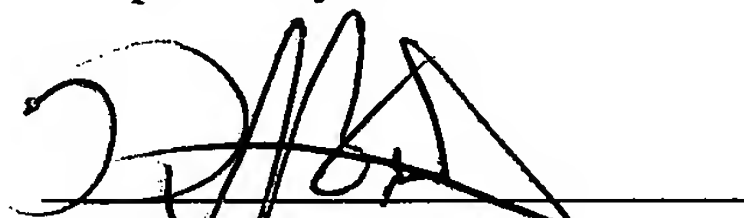
The undersigned has not reviewed the teachings of the above-listed document in detail and thus makes no representations concerning the relevancy or materiality of the above-listed document.

SUBMISSION OF ART
U.S. Appln. No.: 10/659,379

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This is not an Information Disclosure Statement and no response from the U.S. Patent
and Trademark Office is believed to be necessary, nor are any fees believed to be due.

Respectfully submitted,



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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: October 19, 2005